

10/049847

1011 Rec'd PCT/PTO 19 FEB 2002

EPO-1449

Attorney:

Application No.:

19387.0

**INFORMATION DISCLOSURE CITATION**

Applicant:

DAVID FENSTERMACHER

Christer

PRIMARY EXAMINER

Lundström et al.

Filing Date:

Group Art Unit:

February 19, 2002

3682

**U.S. PATENT DOCUMENTS**

Examiner Initial	Ref. No	Document Number	Date	Name	Class	Sub-Class	Filing Date
<i>Jmf</i>	1	4,592,697	06/03/1986	Tuda et al.			

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub-Class	Translation Yes/No
<i>Jmf</i>	2	0947296	10/06/1999	EPO			
<i>Jmf</i>	3	10-225891	08/25/1998	Japan			Abstract

**OTHER DOCUMENTS (Including Author, Title, Date, etc.)**


Examiner DAVID FENSTERMACHER  
PRIMARY EXAMINER *Jmf*

Date Considered

7/14/03

Examiner: Initial if reference consider, whether or not citation is in conformance with MPEP §609.

Draw line through citation if not in conformance and not considered.

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